



Docket No.: N9460.0018/P018
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Hisayuki Takasu et al.

Application No.: 10/705,845

Art Unit: 2851

Filed: November 13, 2003

Examiner: Della J. Rutledge

For: METHOD OF DEVELOPING A RESIST
FILM AND A RESIST DEVELOPMENT
PROCESSOR

AMENDMENT

U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Dear Sir:

Responsive to the Office Action dated June 29, 2005, please amend the above-referenced application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.